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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : S. Yamazaki, et al.                      Art Unit : 1765  
Serial No. : 09/966,689                              Examiner : Kin-Chan Chen  
Filed : September 27, 2001  
Title : DRY ETCHING APPARATUS, ETCHING METHOD AND METHOD OF  
FORMING A WIRING

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF SEPTEMBER 3, 2003

Please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 8 of this paper.